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00862.022239

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shigeyuki UZAWA et al.

Application No.: 09/864,309

Filed: May 25, 2001

For: EXPOSURE APPARATUS, COATING/
DEVELOPING SYSTEM, DEVICE
MANUFACTURING SYSTEM, DEVICE
MANUFACTURING METHOD,
SEMICONDUCTOR MANUFACTURING
FACTORY, AND EXPOSURE APPARATUS
MAINTENANCE METHOD

Examincr: R. A. Jarrett

Croup Art Unit: 2125

Confirmation No.: 2803

February 5, 2004

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of these documents are also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE UST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if nocessary)		ATTY DOCKET NO. 00862.022239 APPLICATION NO. 09/864,309				
		APPLICANT Shigeyuki UZAWA et al.				
	February 5, 2004		FILING DATE May 25, 2001		9ROUP 2125	
			U.S. PAYENT DOCUMENTS		· · · · · · · · · · · · · · · · · · ·	
-EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US-5,524,131	06/04/1996	Uzawa et al.	378	34	
	US-5,822,389	10/13/1998	Uzawa et al.	378	34	
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		FÖR	EIGN PATENT DOCUMENTS		<u> </u>	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YESINO! OR ABSTRACT
	от	HER DOCUMENT(S)	(Including Author, Title, Date, Perlinent Pages, Etc.)			.
EXAMINER			DATE CONSIDERED		,	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 600; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet_1 of

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